

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

September 12, 2025

IGI Report Number

LG731589722

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

TRIANGULAR MIXED CUT

Measurements

8.76 X 10.34 X 4.21 MM

GRADING RESULTS

Carat Weight

1.59 CARAT

Color Grade

E

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence


NONE

Inscription(s)

 LG731589722

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

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
Symmetry

EXCELLENT

Fluorescence

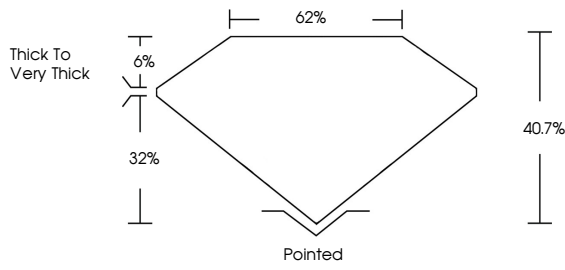
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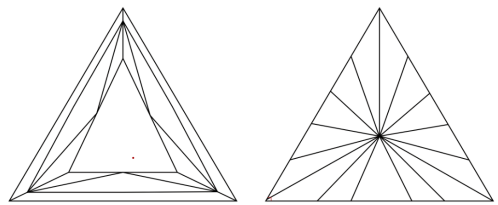
PROPORTIONS





Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR



D E F G H I J Faint Very Light Light

CLARITY

IF VS 1-2 VS 1-2 SI 1-2 I 1-3

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

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TRIANGULAR MIXED CUT

8.76 X 10.34 X 4.21 MM

Carat Weight

1.59 CARAT

Color Grade

E

Clarity Grade

VVS 2

Depth

40.7%

Table

62%

Grade

Thick To Very Thick

Culet

Pointed

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence

NONE

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